



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI, et al.

Group Art Unit: 2881

Serial No.: 09/891,511

Examiner: Berman, Jack I.

Filed: June 27, 2001

P.T.O. Confirmation No.: 8779

FOR: INSPECTION SYSTEM BY CHRGED PARTICLE BEAM AND METHOD OF
MANUFACTURING DEVICE USING THE SYSTEM

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: February 3, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the
Office Action dated October 3, 2003 for 1 month from January 3, 2004 to February 3, 2004.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension
for a large entity. In the event that any additional fees are due in connection with this paper,
please charge our Deposit Account No. 50-2866.

02/06/2004 SMINASS1 00000081 09891511

02 FC:1251

Respectfully submitted,

110.00 DP

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Michael N. Lau

Attorney for Applicant

Reg. No. 39,479

MNL/asc

Atty. Docket No. 010819 Suite 700 1250 Connecticut Ave, N.W. Washington, D.C. 20036 (202) 822-1100		*38834* PATENT TRADEMARK OFFICE
---	--	---